

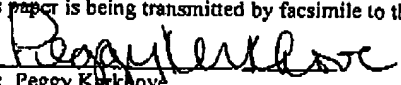
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S/N 10/758,815

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KITAOKA, et al. Examiner: Unknown  
Serial No.: 10/758,815 Group Art Unit: 1754  
Filed: January 16, 2004 Docket: 10873.1384US01  
Title: METHOD OF MANUFACTURING GROUP III NITRIDE  
SUBSTRATE

CERTIFICATE UNDER 37 CFR 1.6(d): I hereby certify that this paper is being transmitted by facsimile to the  
U.S. Patent and Trademark Office on April 18, 2006.

By:   
Name: Peggy Kerkhove

INFORMATION DISCLOSURE STATEMENT (37 C.F.R. § 1.97(c))

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

With regard to the above-identified application, the items of information listed on the enclosed Form 1449 are brought to the attention of the Examiner. Applicants hereby bring attention to the Examiner that they have three commonly assigned co-pending applications, Serial No. 10/804,610 (US Publication No. 2004-0183090) filed March 18, 2004, Serial No. 10/884,252 (US Publication No. 2005-0011432) filed July 2, 2004 and Serial No. 10/969,791 (US Publication No. 2005-0082564) filed October 19, 2004.

This statement should be considered because it is submitted before the mailing date of a first Office Action on-the-merits. Accordingly, no fee is due for consideration of the items listed on the enclosed Form 1449.

In accordance with 37 C.F.R. §1.98(a)(2), a copy of each foreign document or other information listed on the enclosed Form 1449 is provided. As this application was filed after June 30, 2003, copies of the cited U.S. Patent Documents are not included.

A concise explanation of the relevance of each non-English language document or other information is as follows (37 C.F.R. §(a)(3)):

English abstracts have been included for JP 3409576 and JP 2000-357663.

No representation is made that a reference is "prior art" within the meaning of 35 U.S.C. §§ 102 and 103 and Applicants reserve the right, pursuant to 37 C.F.R. § 1.131 or otherwise, to establish that the reference(s) are not "prior art." Moreover, Applicants do not represent that a reference has been thoroughly reviewed or that any relevance of any portion of a reference is intended.

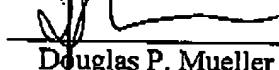
Consideration of the items listed is respectfully requested. Pursuant to the provisions of M.P.E.P. 609, it is requested that the Examiner return a copy of the attached Form 1449, marked as being considered and initialed by the Examiner, to the undersigned with the next official communication.

Please charge any additional fees or credit any overpayment to Deposit Account No. 50-3478.

Respectfully submitted,

HAMRE, SCHUMANN, MUELLER &  
LARSON, P.C.  
P.O. Box 2902-0902  
Minneapolis, MN 55402-0902  
(612) 455-3800

Dated: April 18, 2006

By:   
Douglas P. Mueller  
Reg. No. 30,300

DPM/pjk

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PATENT TRADEMARK OFFICE

Date Mailed: April 18, 2006

Sheet 1 of 1

<b>FORM 1449*</b> <b>INFORMATION DISCLOSURE STATEMENT</b>  <b>IN AN APPLICATION</b> (Use several sheets if necessary)	Docket Number: 10873.1384US01	Application Number: 10/758,815
	Applicant: KITAOKA, et al.	
	Filing Date: January 16, 2004	Group Art Unit: 1754

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	6,121,121	September, 2000	Koide				
	6,270,569	August, 2001	Shibata, et al.				
	6,503,610	January, 2003	Hiramatsu, et al.				
	2003/0042496	March, 2003	Sasaoka				
	6,592,663	July, 2003	Sarayama, et al.				
	6,667,252	December, 2003	Miyajima, et al.				
	2004/0124434	July, 2004	D'Evelyn et al.				
	2004/0147096	July, 2004	Kitaoka, et al.				
	2004/0183090	September, 2004	Kitaoka, et al.				
	2005/0082564	October, 2004	Kitaoka, et al.				
	2005/0011432	January, 2005	Kitaoka, et al.				
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	3409576	March, 2003	Japan			Abstract	
	2000-357663	December, 2003	Japan			Abstract	
	2004/013385	February, 2004	WIPO				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Kawamura, et al., "Growth of a Large GaN Single Crystal Using the Liquid Phase Epitaxy (LPE) Technique", Jpn. J. Appl. Phys., vol. 42, part 2, no. 1A/B, January 15, 2003, pp. L4-L6					

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EXAMINER	DATE CONSIDERED
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	

\*Substitute Disclosure Statement Form (PTO-1449)

Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE